Appln No.: 10/046,559

Applicant(s): John Timothy Strom

IETHOD AND PROCESS OF APPLYING THE

CRUB MARK MORPHOLOGY AND LOCATION THE

EVALUATION AND CORRECTION OF SEMICONDUCTOR
TESTING, ANALYSIS, AND MANUFACTURE

1/3

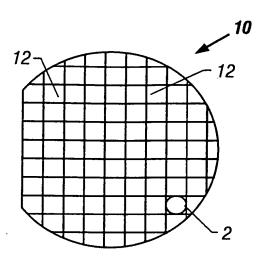


FIG. 1

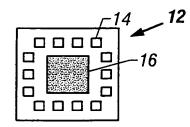


FIG. 2

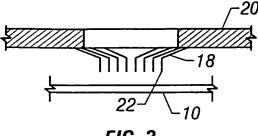
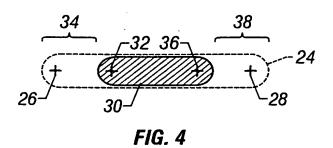
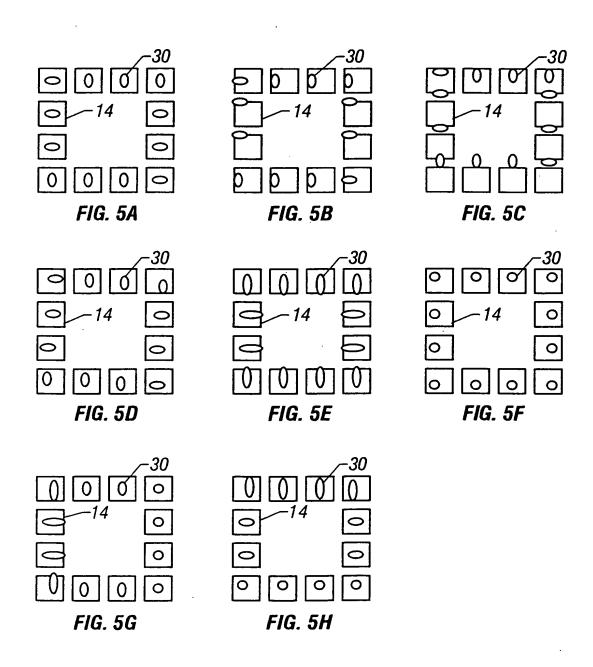


FIG. 3

Appln No.: 10/046,559 Page 2 of 3
Applicant(s): John Timothy Strom
HOD AND PROCESS OF APPLYING THE AND IS OF
UB MARK MORPHOLOGY AND LOCATION TO THE
EVALUATION AND CORRECTION OF SEMICONDUCTOR
TESTING, ANALYSIS, AND MANUFACTURE

2/3





Appln No.: 10/046,559

Applicant(s): John Timothy Strom

THOD AND PROCESS OF APPLYING THE AND SIS OF REVALUATION AND CORRECTION OF SEMICONDUCTOR TESTING, ANALYSIS, AND MANUFACTURE

3/3

